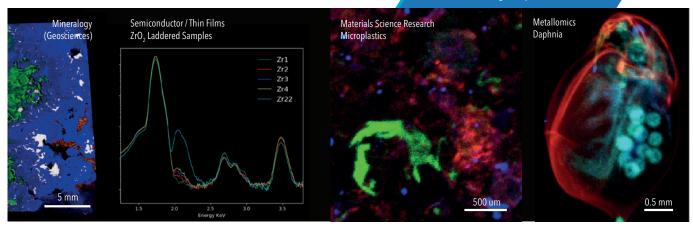






Applications include trace elements in life sciences (metallomics), mineralogy (organics & rare earths), and semiconductor high-k dopants & film thicknesses



Bring Synchrotron XRF Capabilities to Your Lab

Conduct Ground-breaking Research without Needing to Apply for Beamtime

Sigray's AttoMap[™]x-ray fluorescence microscopes are breakthroughs in lab-based elemental imaging performance, bringing synchrotron capabilities to individual laboratories.

What is Fluorescence Microscopy?

X-ray fluorescence (XRF) microscopy is a powerful spatially-resolved elemental mapping and chemical microanalysis technique originally developed and advanced at x-ray synchrotron sources. The technique uses a microfocused x-ray beam that is rastered across the surface of a sample. These x-rays will excite atoms within the sample and result in the production of characteristic x-rays that can be used to determine the elemental composition of the sample.

Why Sigray's Approach?

The AttoMap provides unprecedented sensitivity to detect elements that were previously undetectable with electron-based techniques and conventional microXRF systems. Its performance is enabled by patented innovations: Sigray's patented x-ray source and high efficiency double paraboloidal x-ray optics. The instrument provides fast, non-destructive chemical mapping at single digit microns resolution with times down to 5 milliseconds per point.

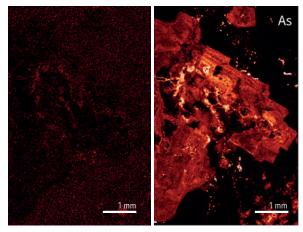


Figure 1: Sigray's patented x-ray source in combination with its multi-optics system enables **energy tunability**, a capability not possible outside of the synchrotron. By switching to different x-ray source targets (which changes incident x-ray energy), sensitivity for an element can be increased up to 1000X. Above is the Arsenic channel of the same geological sample at different incident energies (W source/optic, left, vs. Mo source/optic, right).





AttoMap-300 Specifications

Specification	
Resolution <8 μm	
Sub-ppm relative detection sensitivity and capable of mapping trace elements. Picogram to femtogram absolute sensitivity (element & acquisition time dependent)	
Optical microscopy and x-ray transmission microscopy included	
54" W x 65.5" H x 38.5" D	
100 x 100 mm (upgrades available upon request)	
0 to 70 degrees, in 0.01 degree increments	
100 x 100 mm standard operation, ~30 x 30 mm at grazing angles 20 mm thickness	
Sigray Patented High Brightness Microfocus Source	
Multiple x-ray targets (up to 4) includes selection from: SiC, Cr, Cu, Rh, W, Mo, Au, etc.	
50 W 20-50 kV 2 mA	
Sigray Twin Paraboloidal X-ray Optics (matched to each target material)	
~80%	
1:1 Magnification Default; Demagnifying optics for higher resolution available upon request	
Platinum (increases collection efficiency of optic significantly)	
SDD Detector, 30 mm ²	
<129 eV at Mn-Ka <=136 eV at 5.9 keV	

Comparison: AttoMap-200 and AttoMap-300

Parameter	AttoMap-200	AttoMap-300
Element Range	Na to U	B to U
Variable Angle Acquisition	Normal Incidence (0 degree) and flip-up stage (70 degree)	Enables full range of acquisition angles from 0 to 70 degrees
Diffraction Peak Removal	Can identify (using dual detector option)	Can fully remove (by optimizing angle)
X-ray Source Targets	Cr, Cu, Au, Mo, Rh, W	SiC, Rh, Cr, Cu, Au, Mo, Rh, W
Silicon Background	Present	Use of SiC x-ray target removes Si background (impt for semi & geo)
Stage Travel	200 x 200 mm standard Upgradeable to 300 x 300 mm	100 x 100 mm Upgrades available upon request
Detector	Large format, high performance SDD	High grade SDD optimized for low energy
Vacuum Capabilities	He-flush	Vacuum chamber



